

Electronic Patent Application Fee Transmittal

Application Number:	10736007			
Filing Date:	15-Dec-2003			
Title of Invention:	SINGLE WAFER CLEANING METHOD TO REDUCE PARTICLE DEFECTS ON A WAFER SURFACE			
First Named Inventor:	Christopher Laurent Beaudry			
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Attorney Docket Number:	8034 USA L/W-C/W-C/JB1			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Utility Appl issue fee	1501	1	1400	1400
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Total in USD (\$)				1700